

Advanced Manufacturing of High Performance Superconductor Wires

DE-EE0007869

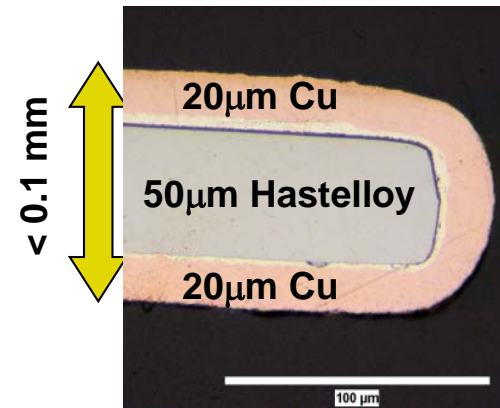
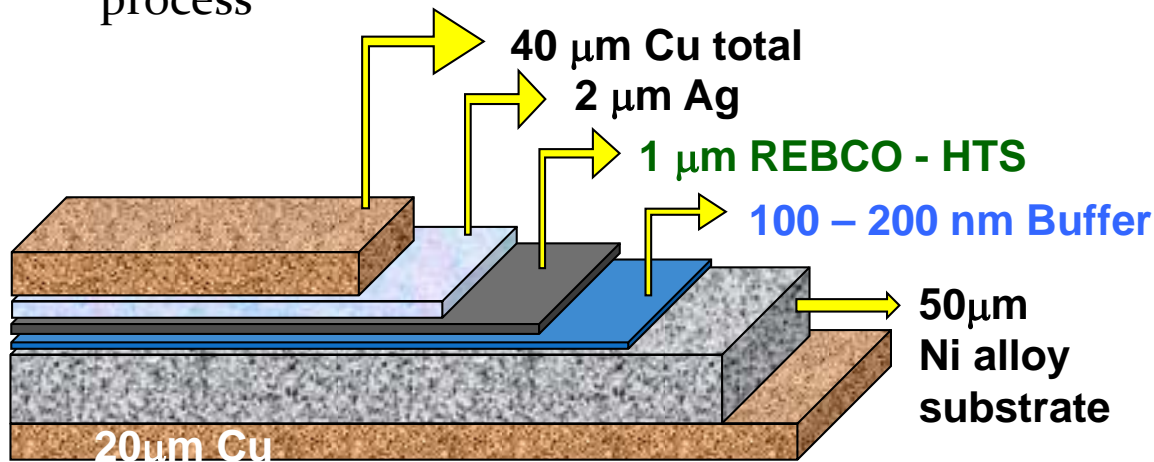
**University of Houston, SuperPower, E2P Solutions, TECO-Westinghouse
Budget Period 1**

Venkat Selvamanickam
University of Houston

U.S. DOE Advanced Manufacturing Office Program Review Meeting
Washington, D.C.
June 13-14, 2017

Background: HTS Wires

- HTS wire is produced by thin film vacuum deposition on a flexible nickel alloy substrate in a continuous reel-to-reel (R2R) process.
 - Only 1% of wire is the superconductor
 - ~ 97% is inexpensive nickel alloy and copper
 - Automated, reel-to-reel continuous manufacturing process



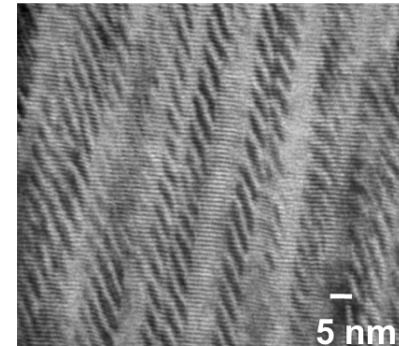
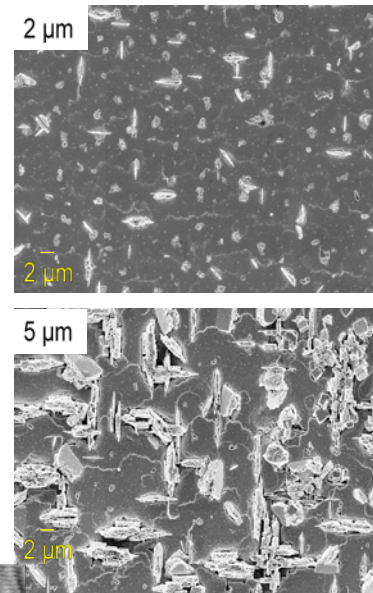
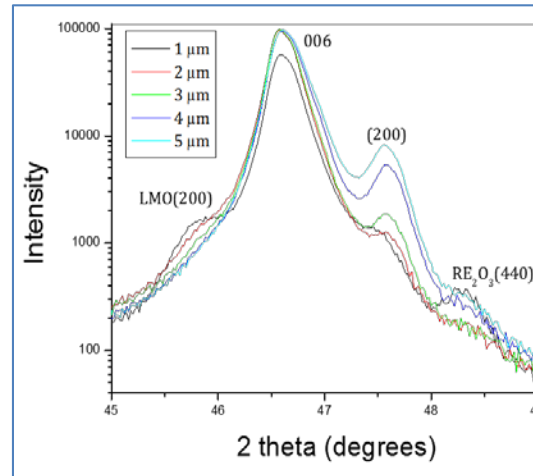
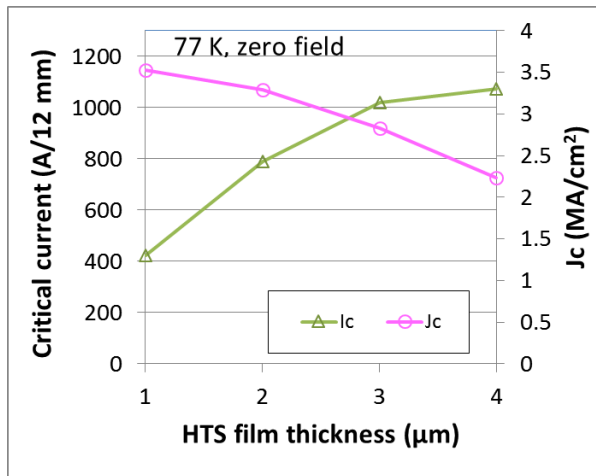
- HTS wire is manufactured in piece lengths of 100 – 500 m with 400X the current carrying capacity of copper wire
- But at \$340/kA-m (based on 65 K, 1.5 T performance), it is 10X price of copper wire

Project Objective

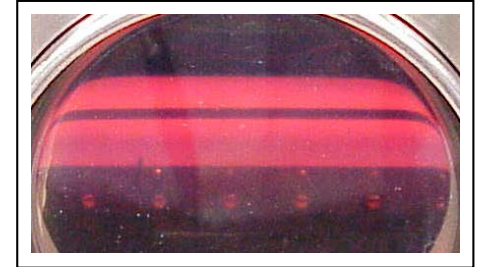
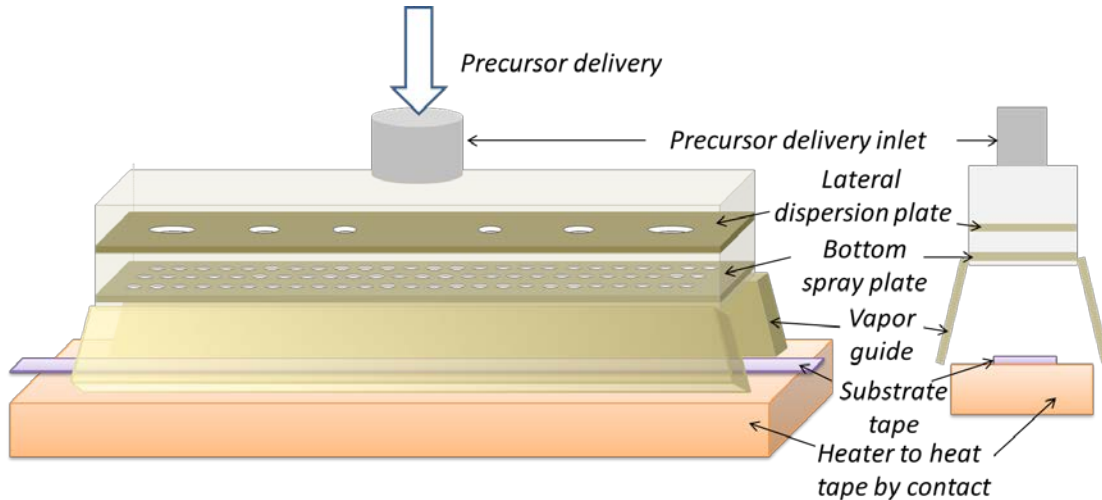
- Enable commercial use of RE-Ba-Cu-O (REBCO) superconductor wires in next-generation electric machines
 - Reduce wire price by **10X** to \$33/kA-m based on performance at 65 K, 1.5 T.
 - Improve the critical current (I_c) at 65 K, 1.5 T by **> 4X** to 1440 A/cm as well as reduce the wire cost by ~50%.
 - Demonstrate advanced manufacturing process for low-cost production of REBCO wires with superior performance.
 - Scale up advanced high I_c , low-cost wire to 50 m lengths.
 - Demonstrate the viability of the advanced REBCO wire for use in motors operating at 65 K
 - Design, construct and test a rotor coil for a 500 HP motor.

Technical Innovation: Opportunities and Challenges

- Increase critical current (I_c) by increasing film thickness from 1.5 μm to 4 μm .
- Increase I_c with a high density of nanoscale defects (e.g.) BaZrO_3 (BZO)
- Reduce cost by improving precursor-to-film conversion efficiency (precursor is highest cost component)

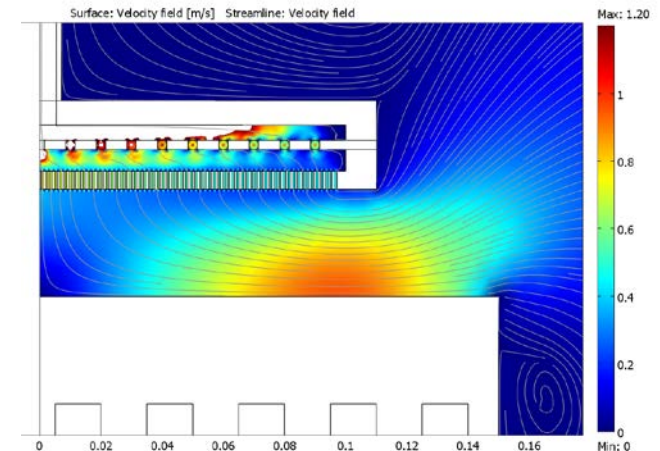


Challenge: Deficiencies of conventional manufacturing



Contact heating in conventional Metal Organic Chemical Vapor Deposition (MOCVD)

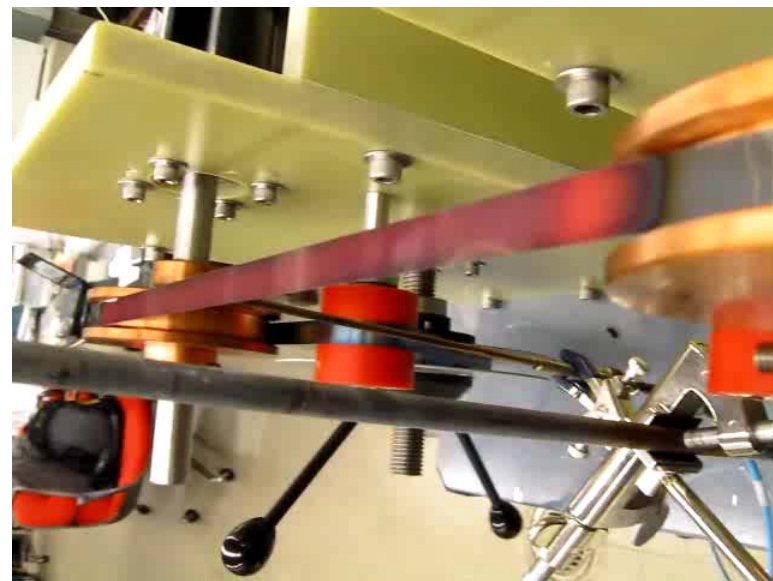
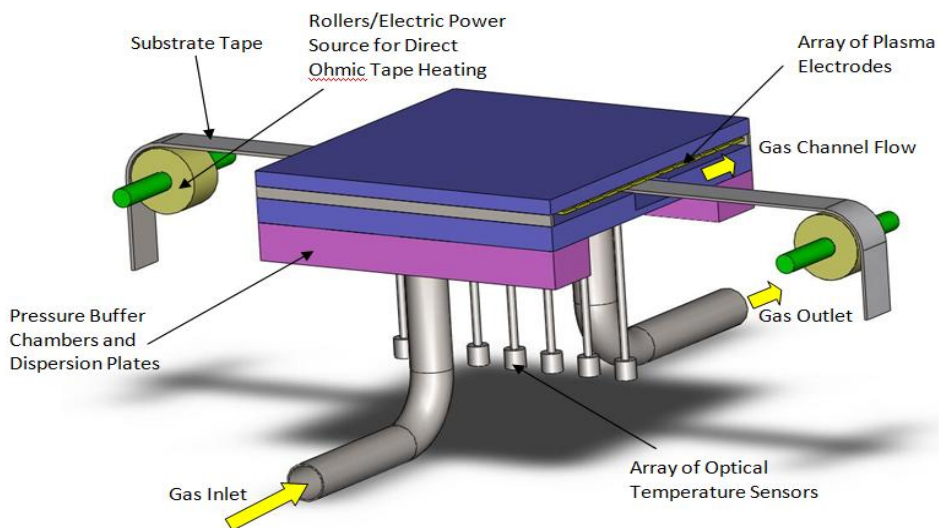
- Poor temperature control and precursor flow non uniformity in conventional R2R MOCVD wire manufacturing → reduction in J_c of thick films, inconsistent growth of nanoscale defects and low manufacturing yield of high I_c wires
- Highly turbulent precursor flow → very inefficient conversion of expensive precursor to film (~ 15%)



Existing MOCVD reactor design is not suitable for level of process control needed for high and consistent performance and for cost effective material use

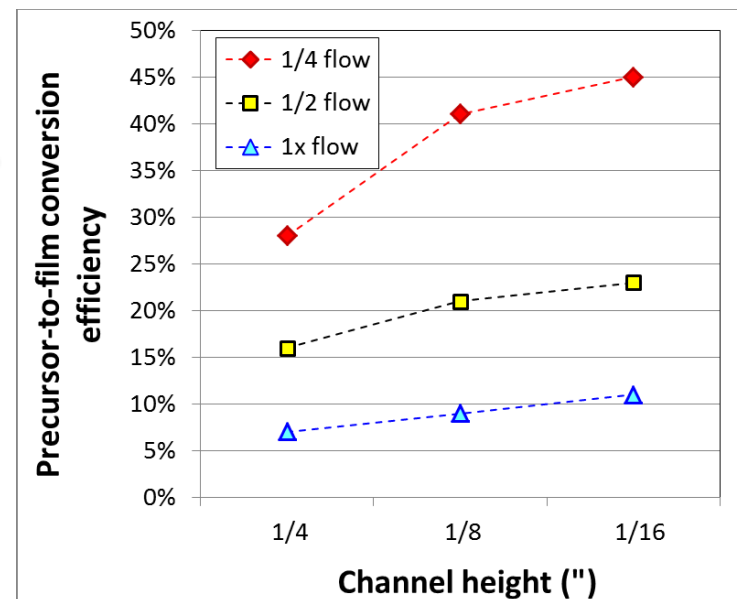
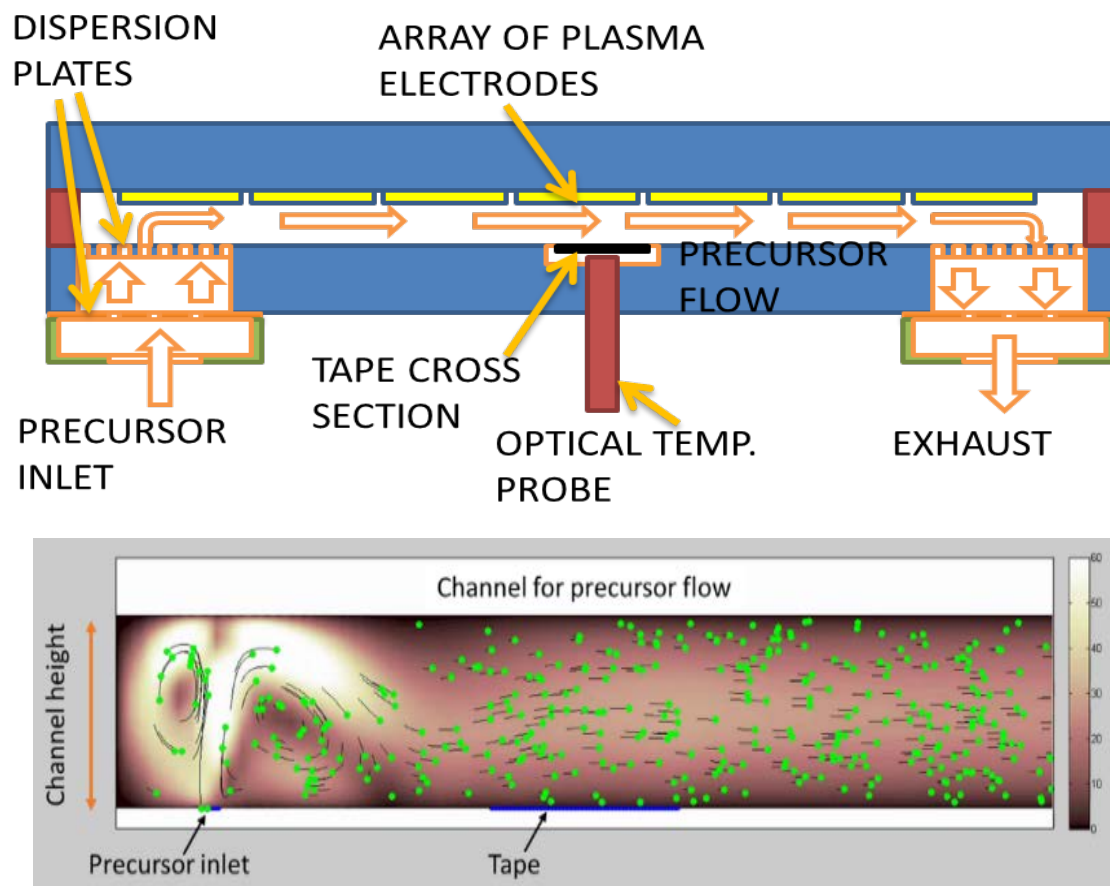
Technical Approach: Advanced MOCVD

- New reactor to address all deficiencies of current production tools designs
 - Derived from modeling
 - Low volume, laminar flow design for uniform temperature, flow, higher conversion efficiency of precursor to film
 - Direct tape heating, direct tape temperature monitoring
 - Stable precursor delivery system
 - Plasma enhancement for enhanced reaction kinetics



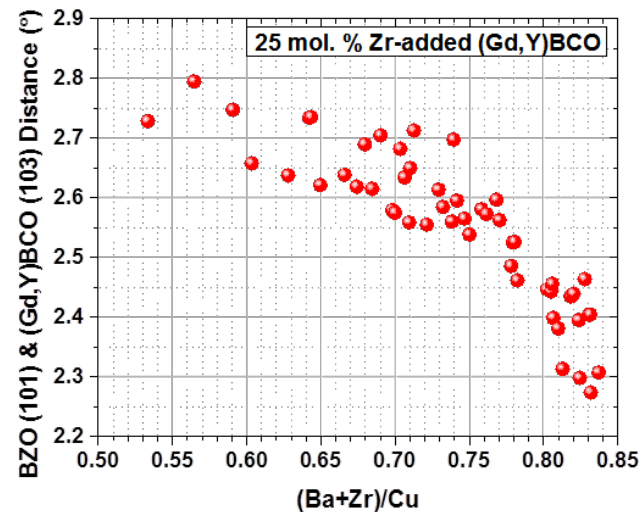
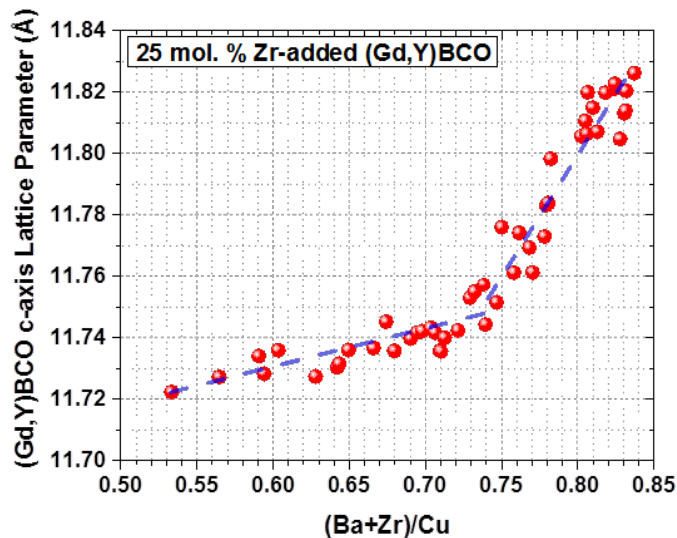
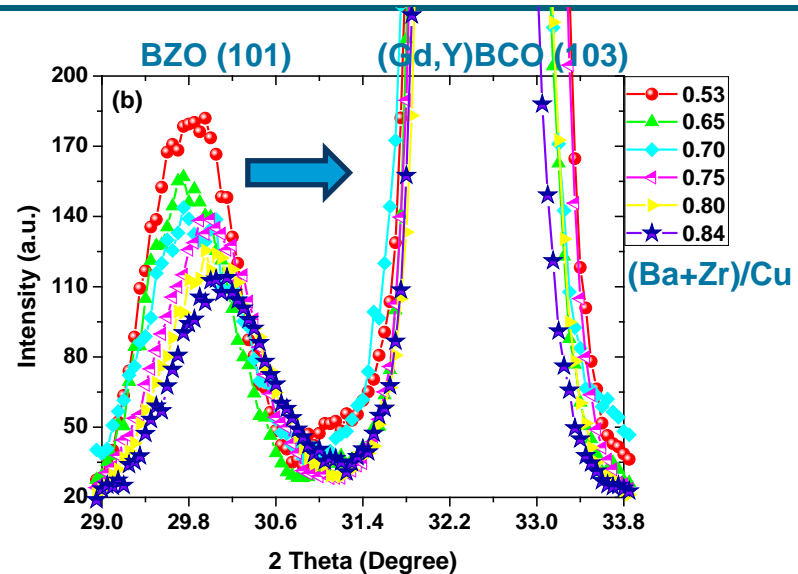
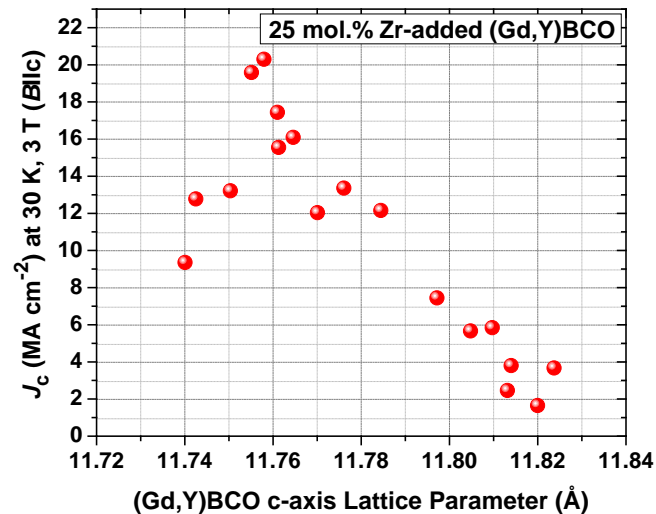
Several new innovative designs implemented in new MOCVD reactor

Technical Approach: Advanced MOCVD



Modeling of flow dynamics in Advanced MOCVD reactor shows 45% (3X) precursor to film conversion efficiency can be attained

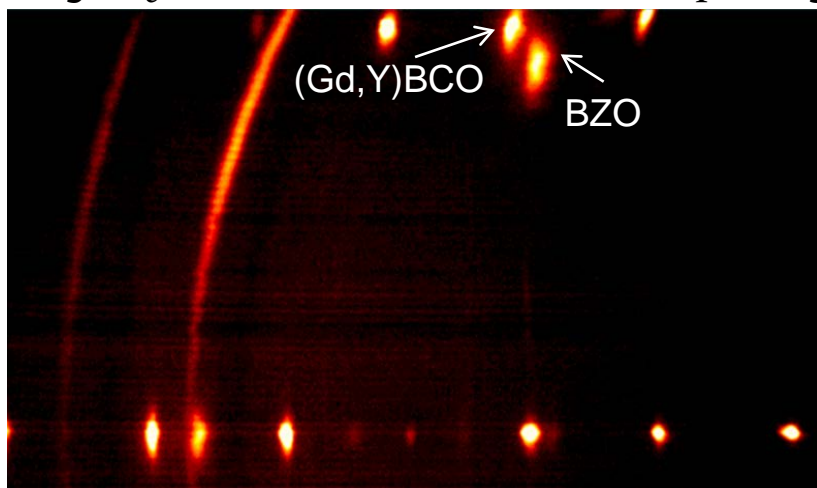
Technical Approach: X-ray Diffraction for QC



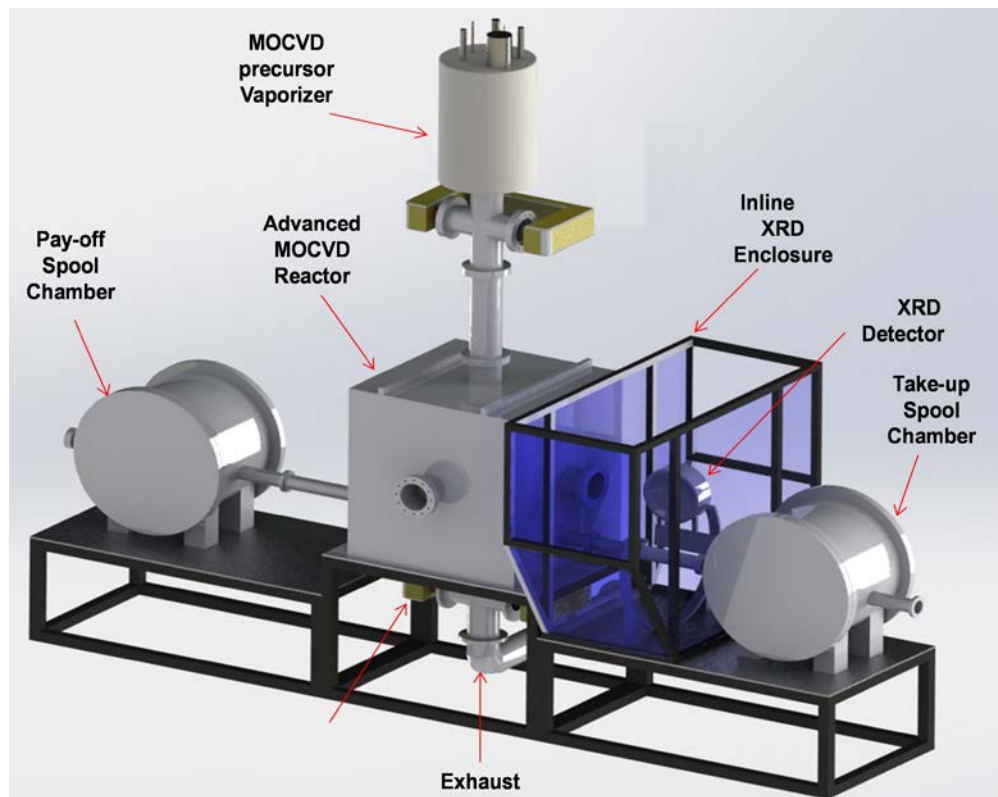
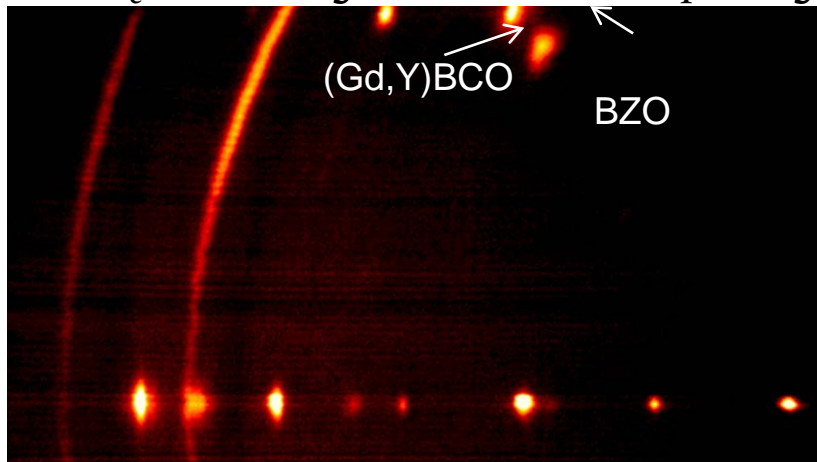
XRD peak spacing of BZO and REBCO is an excellent metric for in-line QC

Technical Approach: In-line XRD

High I_c wire: Small BZO-REBCO spacing



Low I_c wire: Large BZO-REBCO spacing



In-line X-ray Diffraction system in MOCVD manufacturing tool for real-time verification of nanoscale defect growth in HTS film for high-yield manufacturing of high-performance wires

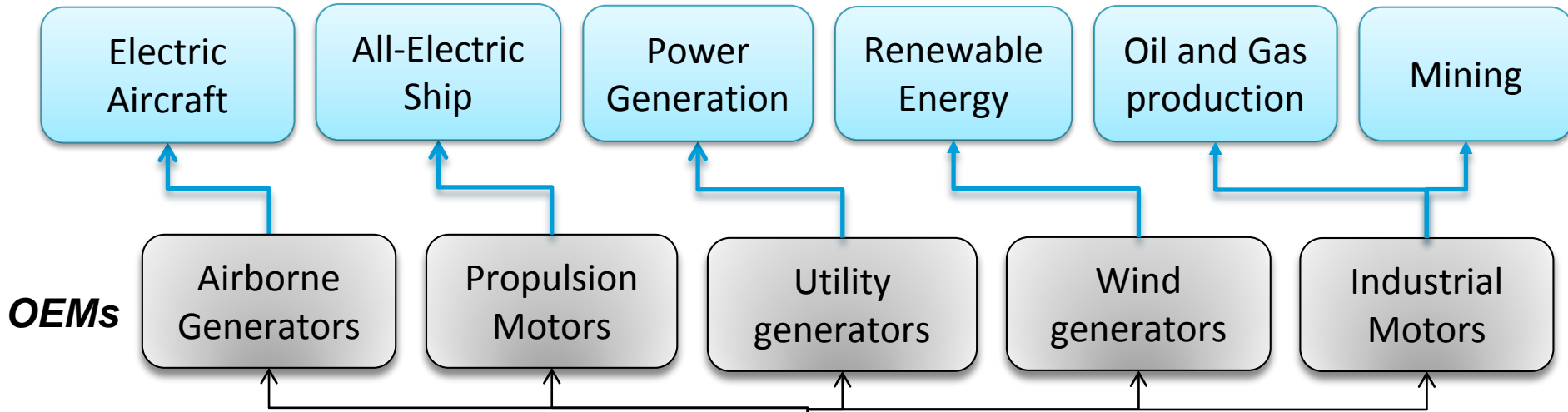
Transition (beyond DOE assistance)

Advanced Manufacturing of High Performance Superconductor Wires will enable commercialization of Next Generation Superconducting Electric Machines through:

- Lower wire cost → Competitive capital cost → Short term for ROI
- Higher operating temperature (65 K) → Simpler cryogenics → Reliability
- Consistency in performance → Predictability
- Higher throughput → High volume production → Availability

Transition (beyond DOE assistance)

End Users



Wire Manufacturers



Measure of Success

	Prod. Wire now	AMO NGEM ₂ Target wire
I _c @ 65 K, 1.5 T (A/cm)	340	1440
Wire quantity for 5.5 MW motor* (km)	5.9	1.3
Wire cost for 5.5 MW motor [†] (\$,(,000))	236	26
% of motor cost ^{**}	67%	8%

- Increased cost of superconducting motor^{††}: \$61,000
- Cost savings/year with superconducting motor[#] ~ \$ 40,000
- **ROI ~ 1.5 years**
- **450 metric tons reduction of CO₂ emissions annually per motor**

* 4 mm wide wire

[†] Wire cost of \$40/m for production wire now, \$20/m (\$35/kA-m) for AMO NGEM₂ target wire

^{**} Using a conventional 6000 HP synchronous motor cost ~ \$350 k

^{††} assuming additional \$35k cost for cryocooler and other technologies

[#] 2% improved efficiency, 18 hour operation, 90% up time, \$ 0.06/kW-h

Fundamental knowledge to be gained

- Influence of internal strain between dopants and superconductor film on the size and orientation of nanocolumnar defects
- Epitaxial superconductor film growth and quality of thick films (4 – 5 μm)
- Effectiveness of flux pinning of nanocolumnar defects of different dopants at 65 K
- Reaction kinetics of superconductor film growth in constrained laminar flow geometry in metal organic chemical vapor deposition (MOCVD) reactor
- Influence of substrate and intermediate buffers on biaxial texture quality in films made by ion beam assisted deposition.

Project Management & Budget

	Year 1	Year 2	Year 3
Performance Metric			
Critical current at 65 K, 1.5 T	800 A/cm	1440 A/cm	1440 A/cm in 50 m long wires
Cost Metric			
Precursor-to-film conversion efficiency	3X improvement	4X improvement	4X improvement in 50 m long wires
Application Verification		Selection of design topology for a 500 HP motor	Construction and testing of one coil at 65 K, made with Advanced wire for 500 HP motor

Total Project Budget	
DOE Investment	\$4,500,000
Cost Share	\$ 1,147,547
Project Total	\$5,647,547

Project Status

- Project started May 5, 2017
- Begun Budget Period 1 tasks
 - Task 1.1.a: Demonstrate 4 - 5 μm thick films with Zr-doped REBCO
 - Task 1.1.b: Find optimum Zr content to maximize retention factor in I_c at 65 K, 1.5 T
 - Task 1.1.c: Optimization of buffer stack for improved texture
 - Task 1.1.d: In-line X-ray Diffraction Quality Control tool development in MOCVD
 - Task 1.2: Improve precursor-to-film conversion efficiency in Advanced MOCVD